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## \*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 17

SERIAL NUMBER 09/813,240	FILING DATE 03/20/2001  RULE	CLASS 257	GROUP ART UNIT 2826	ATTORNEY DOCKE NO. VON AMMON ET AL
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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

GERMANY 100 14 650.3 03/24/2000

in e-file. 9/13/04.

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/22/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDEN
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature	AUSTRIA	0	6	2

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## TITLE

Semiconductor wafer made from silicon and method for producing the semiconductor wafer

FILING FEE  RECEIVED 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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